## 5<sup>th</sup> Fulrath Memorial International Symposium on Advanced Ceramics April 8, 2009 TOKYO BIG SIGHT (Tokyo, Japan)

## ■Program

Time	Session	Lecture Title	Speaker
9:15-9:25		Opening Address	Noboru Ichinose, President; Japan Fulrath Memorial Award Committee
9:25-9:45	General Session 1	Advanced Research & Development Alliance among Industry, University, and Government	<b>Shigekazu Sumita</b> , TDK Corporation
9:45-10:05	General Session 2	High Pressure Synthesis of Silicon Clathrate Superconductors and Carbon Analogs	<b>Shoji Yamanaka</b> , Hiroshima University
10:05-10:25	General Session 3	Laser-Induced Crystallization and Patterning of Ferroelectric Crystals in Glass	<b>Takayuki Komatsu</b> , Nagaoka University of Technology
10:25-10:45	General Session 4	Some Factors Affecting Spark Plasma Sintering	Yoshio Sakka and Salvatore Grasso, University of Tsukuba and National Institute for Materials Science
10:45-11:00	Break		
11:00-11:20	General Session 5	Microwave Dielectric Losses Caused by Lattice Defects	Hiroshi Tamura, Murata Manufacturing Co., Ltd.
11:20-11:40	General Session 6	Intrinsic Dielectric Loss and Effect of Oxygen Defect in Ba(Mg <sub>1/3</sub> Ta <sub>2/3</sub> )O <sub>3</sub> Microwave Ceramics	T.Shimada, K. Ichikawa and T. Minemura, Hitachi Metals LTD.
11:40-12:00	General Session 7	Phase Diagram and Consolidation of Colloidal Nanoparticles	Yoshihiro Hirata, Naoki Matsunaga and Soichiro Sameshima, Kagoshima University
12:00-12:20	General Session 8	Design of Size and Interconnections of Novel Complex Oxide Powders	<b>Satoshi Wada</b> , University of Yamanashi
12:20-12:50	Special Session 1	Chemically Designed Nanoparticles, Nanowires and Nanocomposites: Processing, Applications and Devices	Sanjay Mathur, University of Cologne
12:50-14:10	Lunch Break (13:30-14:30: Special Lecture of Dr. Hiroyuki Yoshikawa, President of AIST: at other meeting room)		
14:10-14:40	Special Session 2	Hertzian Indentation of Si $_3N_4$ Using Si $_3N_4$ Balls	Andrew A. Wereszczak, Oak Ridge National Laboratory
14:40-15:00	General Session 9	Microstructural Design of Dielectrics for Ni-MLCC with Ultra-Thin Active Layers	Youichi Mizuno, Taiyo Yuden Co., Ltd.
15:00-15:20	General Session 10	Ni Paste Study for Ultra Thin MLCC Electrode	<b>Yuji Akimoto</b> , Shoei Chemical Inc.
15:20-15:40	General Session 11	Growth of Polar-axis-oriented Epitaxial Pb(Zr, Ti)O3 Thick Films with Small Strain	Hiroshi Funakubo et al., Tokyo Institute of Technology, Bruker AXS
15:40-16:00	General Session 12	Soft Magnetic Properties of M-Hexagonal Ferrites (Ba,Sr)Fe <sub>12-2x</sub> Co <sub>x</sub> Me <sub>x</sub> O <sub>19</sub> (Me=Ti, Zr, Hf)	Nobuyuki Hiratsuka, Saitama University
16:00-16:10	Break		
16:10-16:30	General Session 13	Recent Development of Nanostructured Thermoelectrics	Kunihito Koumoto, Nagoya University
16:30-16:50	General Session 14	Surface Functions of Bioceramic Electrets	Kimihiro Yamashita, Tokyo Medical and Dental University
16:50-17:10	General Session 15	Towards Innovation in Interface Characterization of Ceramics	Yuichi Ikuhara, The University of Tokyo
17:30-	Reception		